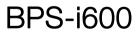


Ultrapure Fluid Handling Integrated Pump System Series





3.1 bar 75 liters/min (45 psi) (20 gallons/min)

No Bearings. No Seals. No Contamination!

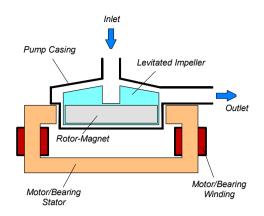


Figure 1: Schematic of the MagLev centrifugal pump

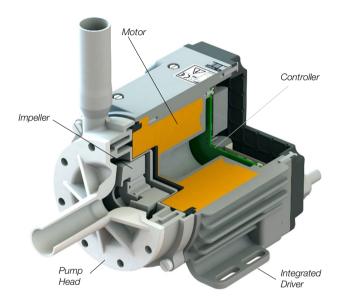


Figure 2: Integrated MagLev pump driver with pump head

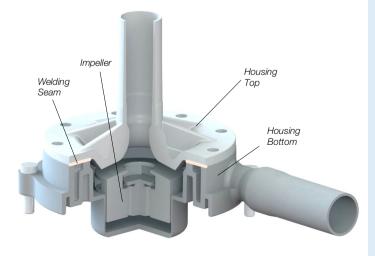


Figure 3: Sealing-less pump head.

INTRODUCTION

The *BPS-i600* pump system is a revolutionary centrifugal pump that has no bearings to wear out or seals to break down and fail. Based on the principles of magnetic levitation, the pump impeller is suspended, contact-free, inside a sealed casing and is driven by the magnetic field of the motor (*Figure 1*).

The impeller and casing are both fabricated from chemicalresistant high purity fluorocarbon resins. Together with the rotor magnet they make up the pump head. The pump housing is welded, hence reducing the risk of contamination and leakage caused by sealing O-rings.

The controller and the motor are integrated into the driver housing (see *Figure 2*). Thus, the cabling effort is reduced. Fluid flow rate and pressure are precisely controlled by electronically regulating the impeller speed without pulsation.

SYSTEM BENEFITS

- Extremely low particle generation due to the absence of mechanically contacting parts and filled sealing O-rings.
- Increased equipment uptime.
- Lower maintenance costs by eliminating valves, bearings, seals and costly rebuilds.
- Very low integration costs as no external controller is needed for speed or closed loop control.
- Reduced risk of contamination due to the self-contained design with magnetic bearings.
- Very gentle to sensitive fluids due to low-shear design.
- No narrow gaps and fissures where particles or microorganisms could be entrapped.
- Smooth, continuous flow without pressure pulsation.
- Electronic speed control.
- Compact design compared to pneumatic and mag-drive pumps.
- Proven technology in medical and semiconductor industry.

APPLICATIONS

- Semiconductor wet processing.
- Flip chip and advanced packaging.
- Solar cell production.
- Flat panel display manufacturing.
- Hard-disk fabrication.
- Printer ink handling.
- Pharmaceutical production.
- Plating.
- Circulation in flow batteries.

SYSTEM CONFIGURATION FOR SPEED CONTROL

Figure 7 illustrates the interfacing of the integrated pump systems. Various PLC signals allow for a simple setup where the pump speed can be precisely set via an analog input. Various digital inputs and outputs allow controlling and monitoring of the system.

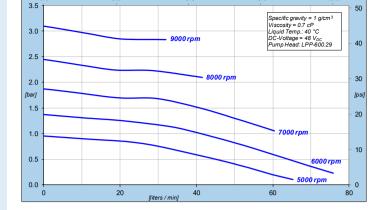
An *RS485* interface allows communication with a PC in connection with the *Levitronix*[®] *Service Software*. Hence parameterization, firmware updates and diagnostics are possible. The *RS485* can also be used as a fieldbus to implement more sophisticated concepts of pump control.

SYSTEM CONFIGURATION FOR PROCESS CONTROL

The *PLC* interface of the *BPS-i600* pump system enables the implementation of precise closed loop flow or pressure control in connection with either a flow or pressure sensor (see *Figure 8*).

Precise ultrapure flow control systems can be realized with the *BPS-i600* pump system in combination with *LEVIFLOW*[®] flowmeters. *Levitronix*[®] provides either turnkey solutions for closed loop flow control or helps to design your own flow control system. Experience has been gained with fluids such as CMP slurries, surface-conditioning chemicals, plating solutions, ultrapure water and solvents.

The versatility of *Levitronix*[®] flow control systems goes far beyond the capabilities of simple flow controllers. In addition to the flow control function, the *Levitronix*[®] control firmware comes with several condition monitoring features to monitor the integrity of the fluid circuit. *Levitronix*[®] flow control systems can generate alarms for preventive filter exchange, no-flow conditions or line clogging. Dynamic Condition Trending (DCT) enables failure prediction and scheduling of preventive maintenance (*Figure 5*).



[gallons/min] 10.0

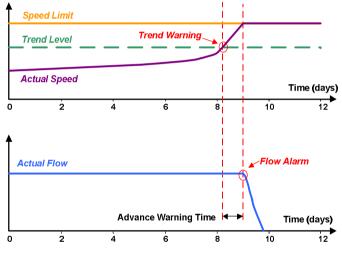
15.0

20.0

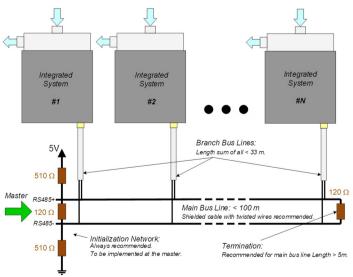
5.0

0.0

Figure 4: Pressure/flow curves for aqueous liquids (Typical data measured with pump head LPP-600.29)

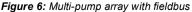






MULTI-PUMP SYSTEM CONFIGURATION

The *RS485* fieldbus (Modbus RTU protocol) allows easy usage of multiple pump arrays (see *Figure 6*) addressing each pump with a unique address, which can be set via *Levitronix*[®] *Service Software*.



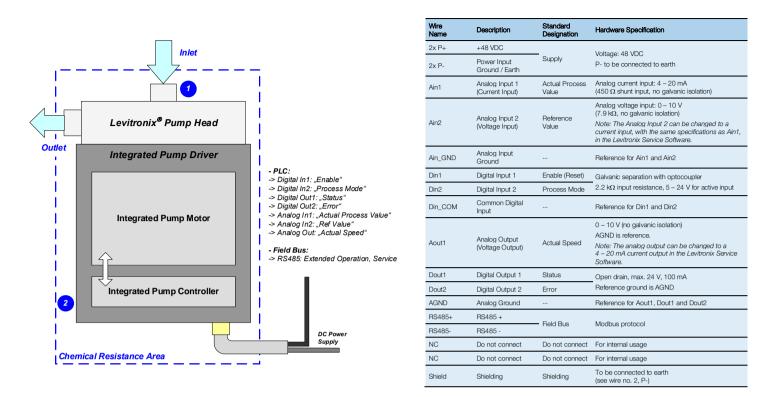


Figure 7: Standard system configuration for speed control

Note 1: Power supply connectiona P+ and P- are 2 connected wires each with 1.5 mm² per wire (total of 3 mm²) and signal wires are 0.14 mm². Note 2: For more detailed description of interface consult user manual.

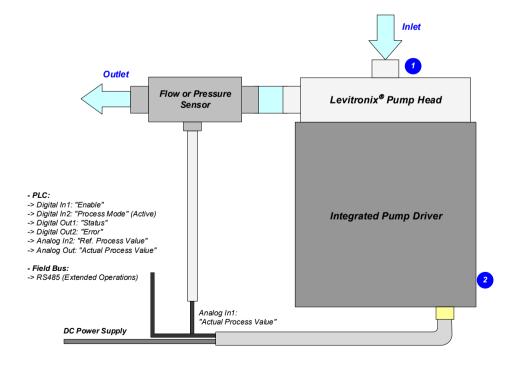


Figure 8: Standard system configuration for process control Note: Parameters of closed loop control can be configured via Levitronix® Service Software over RS485.

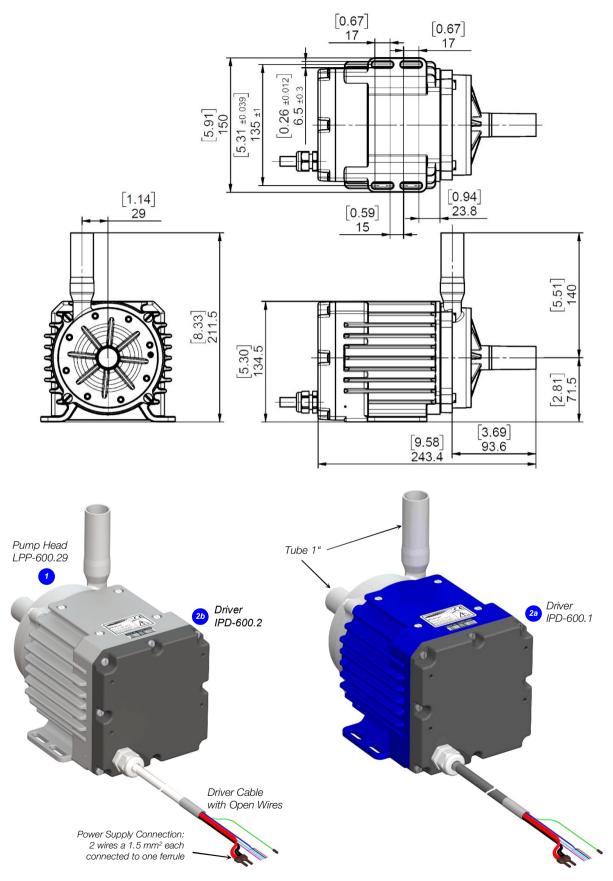


Figure 9: Dimensions of integrated driver with pump head (in mm and [inch]) Note 1: Non-tolerated dimensions are for reference only.

| System Name | Article # | Pump Head | Driver | Note |
|-------------|-----------|------------|-----------------|--|
| BPS-i600.1 | 100-91405 | LPP-600.29 | IPD-600.1-50-01 | PFA pump head, Epoxy coated motor, 5 m PVC cable with open wires |
| BPS-i600.2 | 100-91406 | LPP-600.29 | IPD-600.2-50-01 | PFA pump head, ETFE coated motor, 5 m FEP cable with open wires |

Table 1: Standard system configurations

| Pos. | Component | Article Name | Article # | Characteristics | Value / F | Value / Feature | | |
|------|---------------------------|-----------------|-----------|---|---|--|---|--|
| | | | | Impeller / Pump Housing Housing Sealing Inlet / Outlet Fittings | PFA / PF No sealir Tube 1" | FA ng ring used. Pump hou | using is welded. | |
| 1 | Pump Head | LPP-600.29 | 100-91403 | Max. Flow Max. DiffPressure Max. Viscosity Max. Liquid Temp. | 75 liters// 3.1 bar / 20 cP 90 °C / 1 | , | | |
| 2a | Integrated Pump Driver | IPD-600.1-50-01 | | Voltage, Power Housing | | 48 VDC \pm 10%, 600 W Epoxy (corrosion resistant) coated aluminum, waterproof (IP65) ¹ | | |
| | | | | Cable | PVC jack | PVC jacket, open wires, cable length 5 m | | |
| | | | 100-10179 | Interfaces | PLC with | - 1 analog input - 1 analog input - 1 analog output - 2 digital inputs - 2 digital outputs | 4 – 20 mA 0 – 10 V OR 4 – 20 mA 0 – 10 V OR 4 – 20 mA 0 – 24 V (optocoupler) 0 – 24 V / 100 mA (open drain) | |
| | | | | | RS485 interface (for service and extended field operation). Modbus protocol. | | | |
| | | | | Standard Firmware | 11.48 | | | |
| Ob | Integrated Pump Driver | IPD-600.2-50-01 | 100 10100 | Housing | ETFE (ch | ETFE (chemical resistant) coated aluminum, waterproof (IP65) $^{\scriptscriptstyle 1}$ | | |
| 2b | | | 100-10180 | Cable | FEP jack | et, open wires, cable le | ength 5 m | |

 Table 2: Specification of standard components

 1: Designed and tested for IP67.

| Pos. | Component | Article Name | Article # | Characteristics | Value / Feature |
|------|-------------------------------------|---|-----------|---|---|
| 4 | AC/DC Power Supply | TSP 600-148-M (M = Modified Levitronix design from Traco) | 100-40013 | Voltage / Power Output Voltage Input Certification or Standards | 48 VDC / 600 W 85 – 265 VAC (automatic detection) CB, UL, CSA, Semi F47 |
| 5 | USB to RS485 Adaptor TR Isolated | YN-485I-TR | 100-30392 | Structure / Design | USB connector (A) with termination resistor and cable with connector pair (B and C) for external RS485 wire connection. Magnetically isolated. Cable length is 2 m. Included is a USB space saver cable (D). |
| | | | | Purpose | Communication over fieldbus of driver with PC |
| 6 | Water Cooling Module | WCM-i600.1 | 190-10465 | Materials Motor Mounting Screws | PTFE coated stainless steel for cooling plate (A) and screws (B). 4 x M4x16, Inox A4 (PTFE coated) |
| | | | | Cooling Flow Pressure Drop Max Static Pressure | Min. 0.5 l/min at \leq 20 °C. In- and outlet are NPT 1/8" x 6.9mm. 0.13 bar at 1 l/min (for water at 20 °C) 4 bar |
| | | | | Purpose | Driver cooling for higher liquid temperatures (see user manual). |

Table 3: Specification of standard accessories



Figure 10: Pump system with standard components



Figure 11: Standard accessories

Levitronix® is the world-wide leader in magnetically levitated bearingless motor technology. *Levitronix®* was the first company to introduce bearingless motor technology to the Semiconductor, Medical and Lifescience markets. The company is ISO 9001 certified. Production and quality control facilities are located in Switzerland. In addition, *Levitronix®* is committed to bring other highly innovative products like the *LEVIFLOW®* flowmeter series to the market.



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